



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Trung T. Doan In re application of:

Serial No.: 09/652,969

Filed: August 31, 2000

For: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Examiner: Sylvia Mac AND W 0 3 2003

Group Art Unit: 1763 RECEIVED

Atty. Docket: 93-0420FFICE OF PETITIONS

Mail Stop 313(c) Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Certificate of Mailing

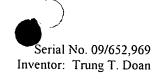
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop 313(c), Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

October 30, 2003

PETITION TO WITHDRAW FROM ISSUE

Dear Sir:

Applicant seeks to withdraw the above captioned application under 37 CFR section 1.313(c)(2) - for consideration of a Request for Continued Examination. Applicants paid the issue fee on October 13, 2003, but have not yet received Notice of Issuance. The Commissioner is authorized to charge the fee of \$130 required under 37 CFR section 1.17(h), as well as any additional fees which may be required, to Micron Technology, Inc., Deposit Account New 13-3092, Order No. 93-0421.05.



Please address further correspondence with this application to: Charles B. Brantley, II, Micron Technology, Inc., Mail Stop 1-525, 8000 S. Federal Way, Boise, ID 83716-9632, telephone number (208) 368-4557.

MICRON, TECHNOLOGY, INC.

Date 10/29/3

Charles B. Brantley II, Reg. No. 38,086

Charles Brantley